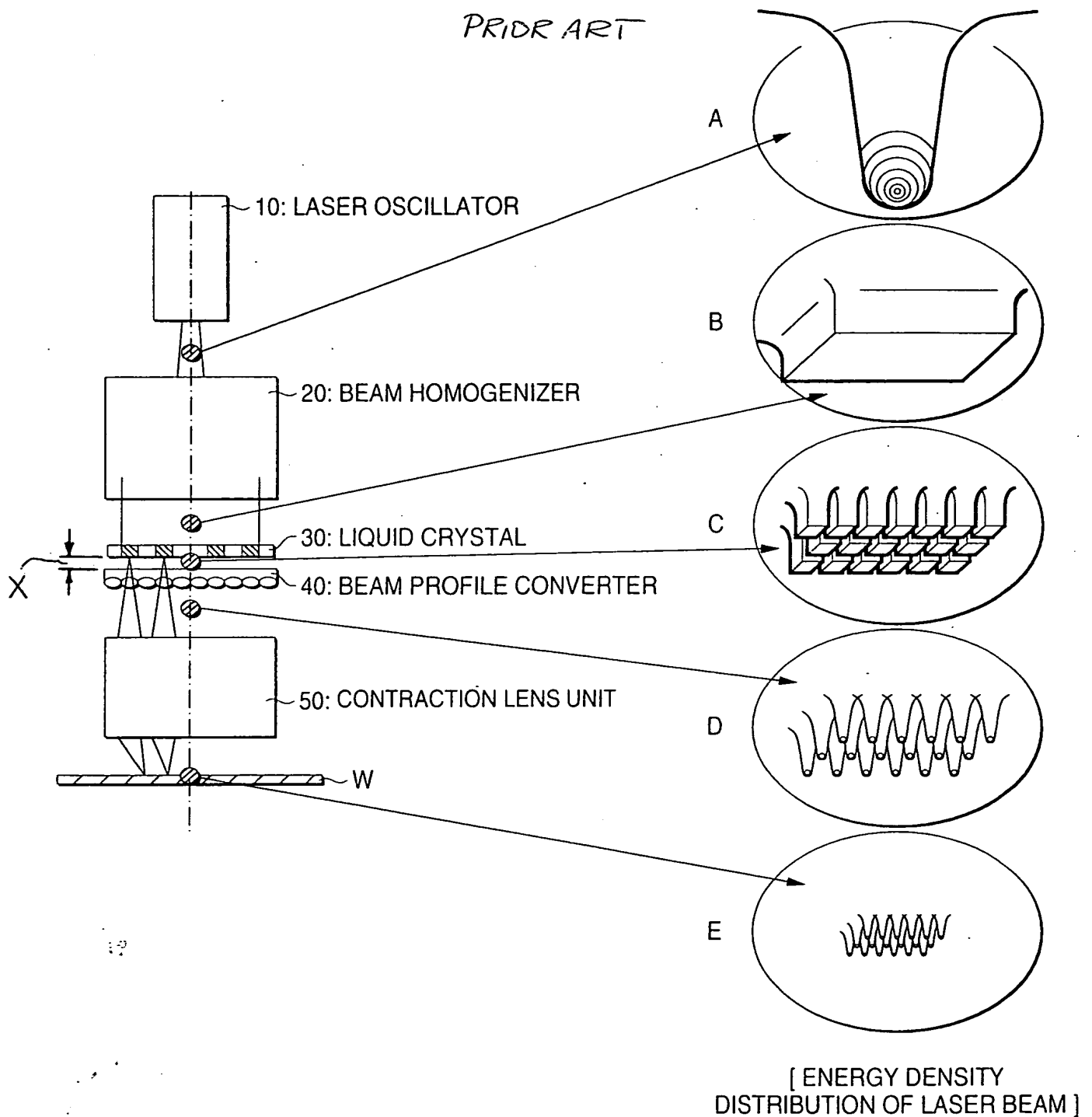



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FIG. 6
PRIOR ART

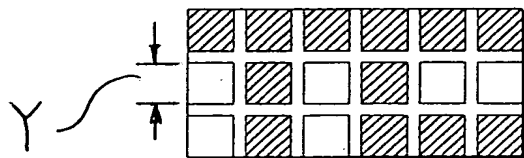


EXPLANATORY VIEW SCHEMATICALLY SHOWING A VERY SMALL DOT MARKING APPARATUS APPLIED TO THE INVENTION AND A PROCEDURE OF CONVERTING AN ENERGY DENSITY DISTRIBUTION (BEAM PROFILE) OF LASER BEAM

FIG. 7
PRIOR ART

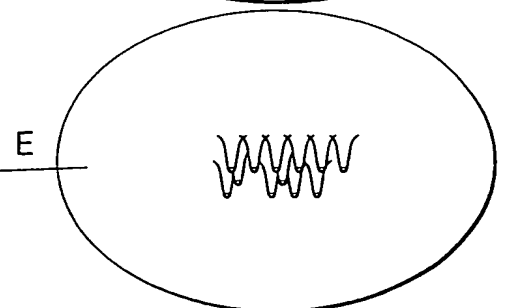
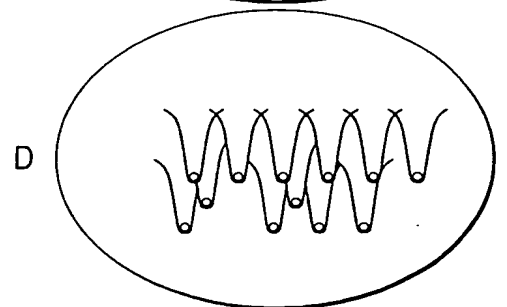
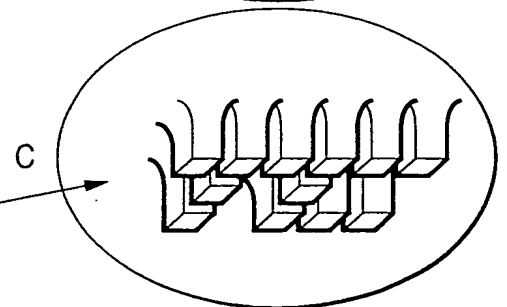
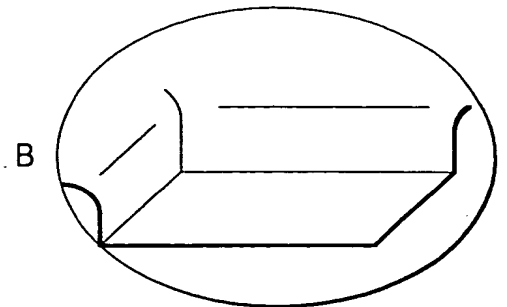
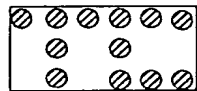
LIGHT TRANSMITTING PORTION
ON LIQUID CRYSTAL MASK 

LIGHT NON-TRANSMITTING PORTION
ON LIQUID CRYSTAL MASK 



30: LIQUID CRYSTAL MASK

DOT MARKS ON SURFACE
OF SEMICONDUCTOR WAFER



EXPLANATORY VIEW SCHEMATICALLY SHOWING DOT MARKS
FORMED IN ACCORDANCE WITH A DISPLAY PATTERN OF A LIQUID
CRYSTAL MASK IN A MARKING APPARATUS AND A PROCEDURE
OF CONVERTING AN ENERGY DISTRIBUTION OF LASER BEAM